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OCT 26 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	Matthew Prince et al.	§	Art Unit:	3723
Serial No.:	10/762,849	§	Examiner:	Hadi Shakeri
Filed:	January 22, 2004	§	Docket:	ITL.0941US P15694
For:	Reducing Wafer Defects from Chemical Mechanical Polishing	§	Assignee:	Intel Corporation

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Commissioner for Patents
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REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed October 11, 2006, reconsideration is requested in view of the following remarks.

A current listing of the claims is attached. No amendments were made.

Date of Deposit: October 26, 2006
I hereby certify that this document is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. 571-773-8300) on the date indicated above.
Cynthia L. Hayden
Cynthia L. Hayden